

Title (en)

SILICON NITRIDE BASED SINTERED COMPACT AND METHOD FOR PRODUCTION THEREOF, AND MEMBER FOR MOLTEN METAL, MEMBER FOR HOT WORKING AND MEMBER FOR EXCAVATION

Title (de)

SINTERKÖRPER AUF SILICIUMNITRIDBASIS UND HERSTELLUNGSVERFAHREN DAFÜR UND ELEMENT FÜR SCHMELZFLÜSSIGES METALL, ELEMENT ZUR WARMFORMGEBUNG UND ELEMENT ZUM AUSSCHACHSEN

Title (fr)

PIÈCE FRITTÉE À BASE DE NITRURE DE SILICIUM ET SON PROCÉDÉ DE FABRICATION, ÉLÉMENT DE MÉTAL EN FUSION, ÉLÉMENT DE FORMAGE À CHAUD ET ÉLÉMENT D'EXCAVATION

Publication

EP 1829844 A1 20070905 (EN)

Application

EP 05809532 A 20051122

Priority

- JP 2005021419 W 20051122
- JP 2004342338 A 20041126

Abstract (en)

A silicon nitride sintered body comprising $\text{Si}_6 - z \text{Al}_z \text{O}_z \text{N}_8 - z$, wherein z value being the dissolved amount is 0.1 to 1, as a main phase, a grain boundary phase and Fe silicide particles. The grain boundary phase contains RE (Group III elements in the periodic table)-Al-Si-O, and component ratios of Al, Si and RE in terms of Al_2O_3 , SiO_2 , RE_2O_3 , respectively is 5 to 50 mass % of Al_2O_3 , 5 to 20 mass % of SiO_2 , and the balanced amount of RE_2O_3 , the grain boundary phase is contained in a range of 20 volume % or less to 100 volume % of the sintered body, and the Fe silicide particles is contained in 0.02 to 3 mass % in terms of Fe to 100 mass % of the sintered body. Its high thermal shock resistance provides suitable applications to members for molten metal, hot working, and digging.

IPC 8 full level

C04B 35/599 (2006.01)

CPC (source: EP US)

C04B 35/591 (2013.01 - EP US); **C04B 35/593** (2013.01 - EP US); **C04B 35/5935** (2013.01 - EP US); **C04B 35/597** (2013.01 - EP US);
C04B 35/64 (2013.01 - EP US); **C04B 35/645** (2013.01 - EP US); **C04B 35/6455** (2013.01 - EP US); **C04B 2235/3217** (2013.01 - EP US);
C04B 2235/3224 (2013.01 - EP US); **C04B 2235/3225** (2013.01 - EP US); **C04B 2235/3229** (2013.01 - EP US);
C04B 2235/3258 (2013.01 - EP US); **C04B 2235/3272** (2013.01 - EP US); **C04B 2235/3418** (2013.01 - EP US);
C04B 2235/3427 (2013.01 - EP US); **C04B 2235/3463** (2013.01 - EP US); **C04B 2235/3852** (2013.01 - EP US);
C04B 2235/3873 (2013.01 - EP US); **C04B 2235/3878** (2013.01 - EP US); **C04B 2235/3882** (2013.01 - EP US);
C04B 2235/3891 (2013.01 - EP US); **C04B 2235/3895** (2013.01 - EP US); **C04B 2235/428** (2013.01 - EP US); **C04B 2235/46** (2013.01 - EP US);
C04B 2235/5436 (2013.01 - EP US); **C04B 2235/5445** (2013.01 - EP US); **C04B 2235/608** (2013.01 - EP US); **C04B 2235/656** (2013.01 - EP US);
C04B 2235/658 (2013.01 - EP US); **C04B 2235/6587** (2013.01 - EP US); **C04B 2235/661** (2013.01 - EP US); **C04B 2235/767** (2013.01 - EP US);
C04B 2235/77 (2013.01 - EP US); **C04B 2235/78** (2013.01 - EP US); **C04B 2235/788** (2013.01 - EP US); **C04B 2235/80** (2013.01 - EP US);
C04B 2235/85 (2013.01 - EP US); **C04B 2235/96** (2013.01 - EP US); **C04B 2235/9607** (2013.01 - EP US)

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US8376624B2; US9097280B2

Designated contracting state (EPC)

DE

DOCDB simple family (publication)

EP 1829844 A1 20070905; **EP 1829844 A4 20100421**; **EP 1829844 B1 20160907**; JP 2012051798 A 20120315; JP 5238161 B2 20130717;
JP WO2006057232 A1 20080605; US 2009023577 A1 20090122; US 7829491 B2 20101109; WO 2006057232 A1 20060601

DOCDB simple family (application)

EP 05809532 A 20051122; JP 2005021419 W 20051122; JP 2006547778 A 20051122; JP 2011259564 A 20111128; US 72027805 A 20051122